



## **NATIONAL AERONAUTICS AND SPACE ADMINISTRATION**

**[Notice: (20-024)]**

### **Notice of Intent to Grant a Partially Exclusive License**

**AGENCY:** National Aeronautics and Space Administration.

**ACTION:** Notice of Intent to Grant Partially Exclusive Patent License

**SUMMARY:** NASA hereby gives notice of its intent to grant a partially exclusive patent license in the United States to practice the inventions described and claimed in U.S.

Patent Number 8,987,632 B2 titled “Modification of Surface Energy via Direct Laser

Ablative Surface Patterning,” NASA Case Number LAR-17769-1; and U.S. Patent

Number 10,259,077 B2 titled “Modification of Surface Energy via Direct Laser Ablative

Surface Patterning,” NASA Case Number LAR-17769-2, to Genetoo, Inc., having its

principal place of business in Gaithersburg, MD. The fields of use may be limited to for

performing laser ablation, on the surface of surgical implants, to enhance specific patterns

and to avoid bacteria growth, and/or similar field(s) of use thereto. NASA has not yet

made a determination to grant the requested license and may deny the requested license

even if no objections are submitted within the comment period.

**DATES:** The prospective partially exclusive license may be granted unless NASA

receives written objections including evidence and argument, no later than [INSERT

DATE 15 DAYS AFTER DATE OF PUBLICATION IN THE *FEDERAL REGISTER*]

that establish that the grant of the license would not be consistent with the requirements

regarding the licensing of federally owned inventions as set forth in the Bayh-Dohl Act

and implementing regulations. Competing applications completed and received by NASA no later than [INSERT DATE 15 DAYS AFTER DATE OF PUBLICATION IN THE *FEDERAL REGISTER*] will also be treated as objections to the grant of the contemplated partially exclusive license. Objections submitted in response to this notice will not be made available to the public for inspection and, to the extent permitted by law, will not be released under the Freedom of Information Act.

**ADDRESSES:** Objections relating to the prospective license may be submitted to Patent Counsel, Office of Chief Counsel, NASA Langley Research Center, MS 30, Hampton, Virginia 23681. Phone (757) 864-3221. Facsimile (757) 864-9190.

**FOR FURTHER INFORMATION CONTACT:** : Robin W. Edwards, Patent Counsel, Office of Chief Counsel, NASA Langley Research Center, MS 30, Hampton, Virginia 23681. Phone (757) 864-3221. Facsimile (757) 864-9190.

**SUPPLEMENTARY INFORMATION:** This notice of intent to grant a partially exclusive patent license is issued in accordance with 35 U.S.C. 209(e) and 37 CFR 404.7(a)(1)(i). The patent rights in these inventions have been assigned to the United States of America as represented by the Administrator of the National Aeronautics and Space Administration. The prospective partially exclusive license will comply with the requirements of 35 U.S.C. 209 and 37 CFR 404.7.

Information about other NASA inventions available for licensing can be found online at <http://technology.nasa.gov>.

**Helen M. Galus,**  
*Agency Counsel for Intellectual Property.*

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